



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Attorney Docket No. 016778/0437**

Applicant: Yukio MORISHIGE et al.  
Title: METHOD AND DEVICE FOR CORRECTING PATTERN  
FILM ON A SEMICONDUCTOR SUBSTRATE  
Application No.: 09/981,712  
Filing Date: October 19, 2001  
Examiner: Hassanzadeh, Parviz  
Art Unit: 1763

**AMENDMENT AND REPLY ACCOMPANYING A FILING OF AN RCE**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 7 of this document.

Please amend the application as follows: